TRANSMITTAL O	Docket No. AM-5209-D2									
In Re Application: Ling CHEN et al. JAN 2 2 2004 8										
Serial No.	Filing Date		Examiner	Group Art Unit						
10/693,775	Filing Date October 24, 2003	RADEMARK	unknown	unknown						
Tantalum Barrier Layer for Copper Metalllization										
		ayment of Fee								
	(Only complete if Applicant	elects to pay the	e fee set forth in 37 C	CFR 1.17(p))						
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ŢRA			ON DISCLOSUI .97(b) or 1.97(c))	RE STATEMENT		Docket No. AM-5209-D2		
In Re Application Of: Ling CHEN et al. JAN 2 2 2004								
	Serial No. 10/693,775	Filing Date Examiner Group Art October 24, 2003 October 24, 2003 October 24, 2003 October 24, 2003 October 24, 2003						
Title: Tantalum Barrier Layer for Copper Metalllization								
			Address i Assistant Commissi Washington, D	oner for Patents				
			37 CFR 1	.97(b)				
1. A The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.								
			37 CFR 1	.97(c)				
2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:								
	the statement specified in 37 CFR 1.97(e);							
		OR) }					
	☐ the fee se	t forth in 37 CFR 1	1.17(p).					

U.S. Department of Commerce, Patent and Trademark Office				Docket 1	Docket No.: AM-5209.D2					
					Serial N	Serial No.: 10/693,775				
LIST OF RELEVANT ART CITED BY APPLICANT				Applica	Applicant: Ling Chen et al.					
H 2 2 2004 8					Filing D	Filing Date: October 24, 2003				
				Group:	Group: Unknown					
& TRADEMEN			τ	J.S. PATENT DOCUMEN	NTS					
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date Appropriate			
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	AB	5,846,332	12/08/98	Zhao et al.	118	728		-		
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	AH	6,284,657	09/04/01	Chooi et al.	438	687				
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		Document Number	Date	Country	Class	Subclass	Yes	No		
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	AM	2000-323571	11/24/00	Japan			Abstract			
		ОТН	ER ART (Incl	uding Author, Title, Date,	Pertinent Page	s, Etc.)				
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